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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Yoshihiro OHMI et al

Serial Number: 09/864,376

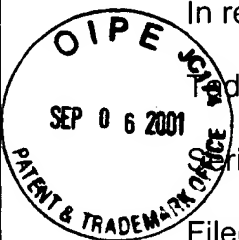
Filed: May 25, 2001

For: PLASMA PROCESSING APPARATUS AND  
PLASMA PROCESSING METHOD

**ATTN: Application Branch**

Confirmation No.: 1605

Atty. Docket No.: 107176-00007



REQUEST FOR CORRECTED FILING RECEIPT

Honorable Commissioner for Patents  
Washington, D.C. 20231

September 6, 2001

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TC 1700

Sir:


Please supply the undersigned attorney with a corrected filing receipt of the above-identified application.

In reviewing the Official Filing Receipt, we noted an error in the second inventor's name. The second inventor's name should read -- Kazuhide INO --. In support of this request, enclosed is a copy of Declaration and Power of Attorney, along with a copy of the filing receipt with the correction highlighted in yellow.

In the event any fees are due with respect to this paper, please charge our Deposit Account No. 01-2300.

Respectfully submitted,

ARENT FOX KINTNER PLOTKIN & KAHN, PLLC

  
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Enclosures: Declaration and Power of Attorney (copy); Official Filing Receipt (copy)



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/864,376	05/25/2001	1763	0.00	107176-00007	4	8	2

CONFIRMATION NO. 1605

## FILING RECEIPT



\*OC000000006348961\*

ARENT FOX KINTNER PLOTKIN & KAHN, PLLC  
Suite 600  
1050 Connecticut Avenue, N.W.  
Washington, DC 20036-5339

Date Mailed: 07/26/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

## Applicant(s)

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Takahiro Arakawa, Kyoto-shi, JAPAN;

## Domestic Priority data as claimed by applicant

## Foreign Applications

JAPAN 2000-156535 05/26/2000

If Required, Foreign Filing License Granted 07/26/2001

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

## Title

Plasma processing apparatus and plasma processing method

## Preliminary Class

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DOCKETING BY *[Signature]*  
DATE 7-31-01

156

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**Data entry by :** ASRAT, FANAYE

**Team :** OIPE

**Date:** 07/26/2001



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Bib Data Sheet

CONFIRMATION NO. 1605

<b>SERIAL NUMBER</b> 09/864,376	<b>FILING DATE</b> 05/25/2001 <b>RULE</b>	<b>CLASS</b> 156	<b>GROUP ART UNIT</b> 1763	<b>ATTORNEY DOCKET NO.</b> 107176-00007	
<b>APPLICANTS</b> Tadahiro Ohmi, Sendai-shi, JAPAN; Kazuhide Ino, Kyoto-shi, JAPAN; Takahiro Arakawa, Kyoto-shi, JAPAN;					
<b>** CONTINUING DATA *****</b>					
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-156535 05/26/2000 <i>RB 9/4/02</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 07/26/2001</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met <i>allowance</i> Verified and <i>Prody Design</i> Acknowledged <i>Examiner's Signature</i> Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 4	<b>TOTAL CLAIMS</b> 8	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> PARENT FOX KINTNER PLOTKIN & KAHN, PLLC Suite 600-400 1050 Connecticut Avenue, N.W. Washington, DC 20036-5339					
<b>TITLE</b> Plasma processing apparatus and plasma processing method					
<b>FILING FEE RECEIVED</b> 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

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